

<b>Notice of References Cited</b>	Application/Control No. 10/750,559	Applicant(s)/Patent Under Reexamination MILLS, MICHAEL J.	
	Examiner Maria N. Von Buhr	Art Unit 2125	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0122165 A1	06-2005	Kim et al.	330/051
*	B	US-2005/0093630 A1	05-2005	Whittaker et al.	330/254
*	C	US-2005/0074115 A1	04-2005	George, Scott A.	379/418
*	D	US-2005/0063534 A1	03-2005	George, Scott A.	379/399.01
*	E	US-2004/0207468 A1	10-2004	Klomsdorf et al.	330/129
*	F	US-2004/0100237 A1	05-2004	Fagnani et al.	323/282
*	G	US-2003/0212916 A1	11-2003	Ito et al.	713/322
*	H	US-6,972,611 B1	12-2005	Thalheim, Jan	327/434
*	I	US-6,839,253 B2	01-2005	Chou et al.	363/84
*	J	US-5,854,839 A	12-1998	Chen et al.	379/413
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.